



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In the application of: Dalton et al.

Attorney Docket No.:  
NOVLP082/NVLS-2893

Application No.: 10/772,109

Examiner: Jarrett Stark

Filed: February 3, 2004

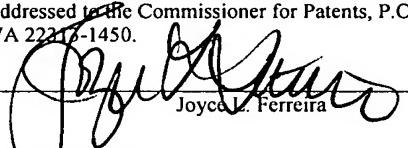
Group: 2823

Title: USE OF METALLOCENES TO INHIBIT  
COPPER OXIDATION DURING  
SEMICONDUCTOR PROCESSING

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on August 28, 2007 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: \_\_\_\_\_

  
Joyce L. Ferreira

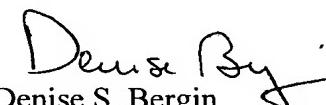
**SEPARATE LETTER TO EXAMINER  
REQUESTING DRAWING APPROVAL**

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Due to informalities in the original drawings enclosed are substitute (formal) drawings for the above-identified patent application. If the Draftsman has any question concerning these drawings, he or she is respectfully requested to contact the undersigned.

Respectfully submitted,  
BEYER WEAVER LLP

  
Denise S. Bergin  
Registration No. 50,581

P.O. Box 70250  
Oakland, CA 94612-0250  
(510) 663-1100